



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Hyungjun KIM et al.

CONFIRM. NO. 3395

SERIAL NO.: 10/699,226

ART UNIT: 1762

FILED: 10/31/2003

EXAMINER: Bret P. CHEN

TITLE: PLASMA ENHANCED ALD OF TANTALUM NITRIDE AND BILAYER

ATTORNEY DOCKET NO.: YOR920030208US1

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.97(d),  
STATEMENT UNDER 37 C.F.R. 1.97(e) (1), AND FEE

In accordance with the duty of disclosure, Applicants call to the attention of the Examiner the documents (3 enclosed) listed on the attached form PTO-1449(substitute). It is respectfully requested that the Examiner consider these documents, and make them of record.

The undersigned certifies that each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

Please charge the required fee of \$180 to deposit account no. 50-0510. A duplicate of this paper is enclosed.

Respectfully submitted,

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1/10/2007

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**INFORMATION DISCLOSURE  
CITATION FORM FOR  
PATENT APPLICATION  
(FORM PTO-1449)  
(Substitute)**

Docket No.: YOR920030208US1

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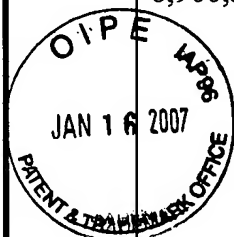
Applicant(s): Hyungjun KIM et al.

Filing Date: 10/31/03

Group: 1762

**U.S. PATENTS**

Initials	Patent Number	Issue Date	Name	Class	Sub-class	Filing date
	6,579,786 6,900,539	6/2003 5/2005	Schmidbauer et. al. Motoyama			

**FOREIGN PATENT DOCUMENTS**

Initials	Document Number	Date	Country	Name	Translation? Yes/No/n/a
	2002-0065245 2003-0001068 WO03/023835	8/13/02 1/06/03 3/20/03	Republic of Korea Republic of Korea PCT	Choi et al. Min Lee et al.	abs abs n/a

**OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)**


Examiner's Signature:

Date Considered:

Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered.  
Include a copy of this citation form with your next correspondence to the Applicant(s).